

Electronic Patent Application Fee Transmittal				
Application Number:		10565107		
Filing Date:		05-Mar-2007		
Title of Invention:		Plasma Surface Processing System and Supply Device for Plasma Processing Solution Therefor		
First Named Inventor/Applicant Name:		Young-Man Jeong		
Filer:		Esther Hyeri Chong/Ruth Calendine		
Attorney Docket Number:		0630-2627PUS1		
Filed as Large Entity				
U.S. National Stage under 35 USC 371 Filing Fees				
Description	Fee Code	Quantity	Amount	Sub-Total in USD(\$)
Basic Filing:				
Pages:				
Claims:				
Miscellaneous-Filing:				
Petition:				
Patent-Appeals-and-Interference:				
Post-Allowance-and-Post-Issuance:				
Extension-of-Time:				
Extension - 1 month with \$0 paid	1251	1	130	130

Description	Fee Code	Quantity	Amount	Sub-Total in USD(\$)
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Total in USD (\$)				130